United States Patent [19]

Yamada

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[54] **VIEWER ATTACHMENT FOR A MICROSCOPE**

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[**] Term: **14 Years**

[21] Appl. No.: **730,074**

[22] Filed: **May 3, 1985**

[52] **U.S. Cl.** **D16/131;** D16/136

[58] **Field of Search** D16/130–137;
350/502, 507, 508, 516, 571, 145

[56] **References Cited**

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[57] **CLAIM**

The ornamental design for a viewer attachment for a microscope, as shown.

DESCRIPTION

FIG. **1** is a right side elevational view of the viewer attachment for a microscope showing my new design;
FIG. **2** is a front elevational view thereof;
FIG. **3** is a rear elevational view thereof;
FIG. **4** is a left side elevational view thereof;
FIG. **5** is a top plan view thereof; and
FIG. **6** is a bottom plan view thereof.

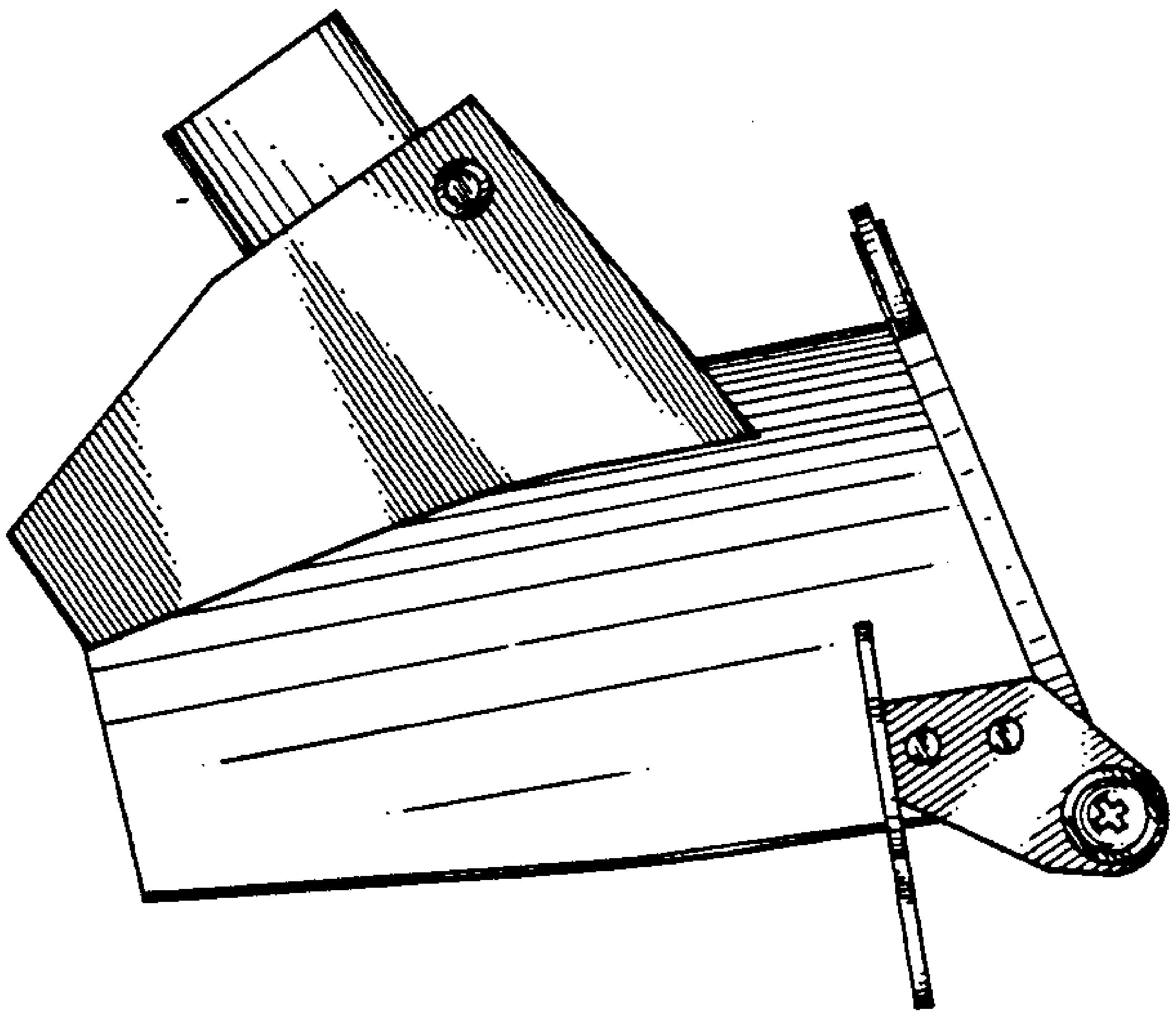

Fig. 2

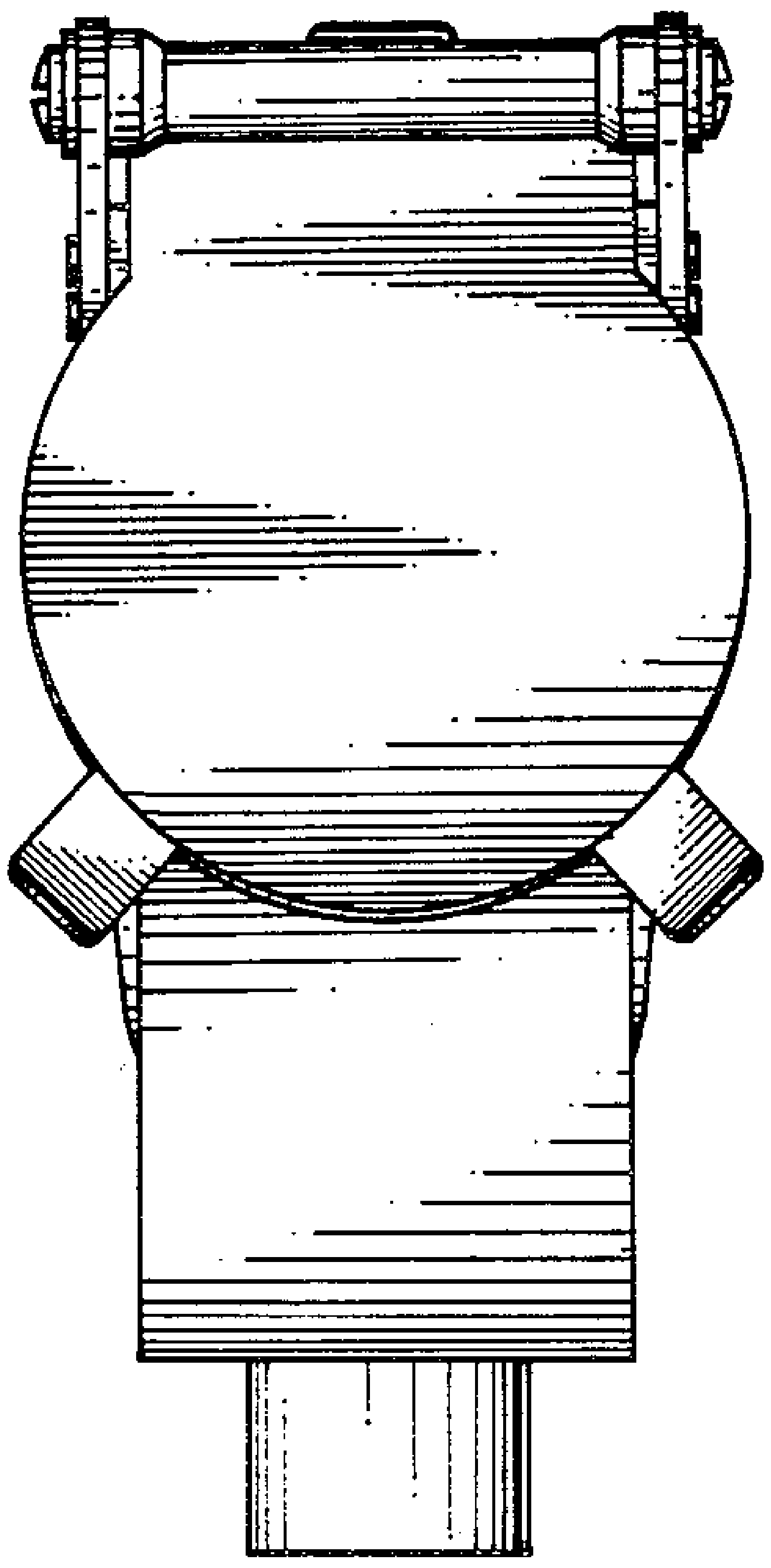

Fig. 1

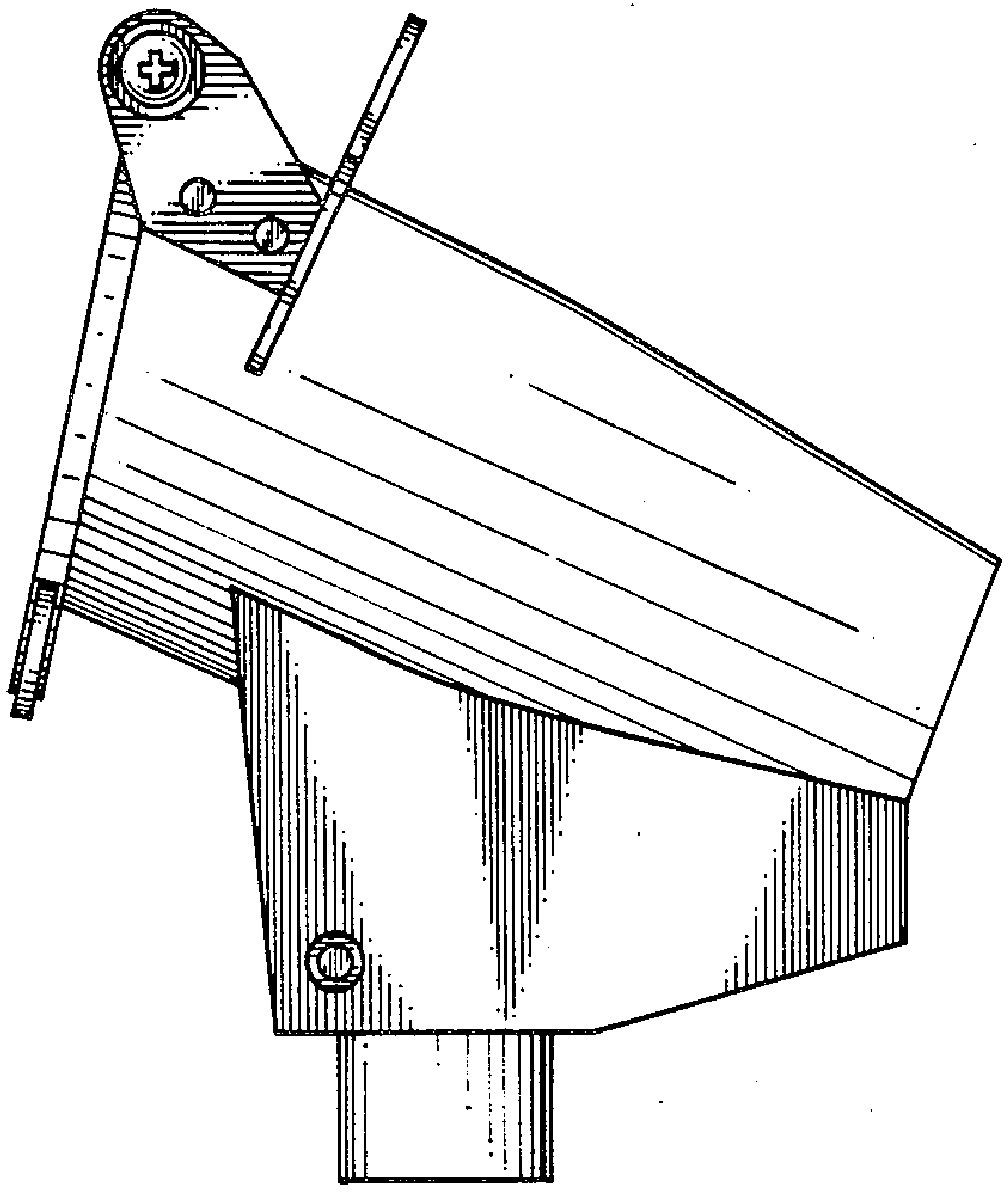

Fig. 4

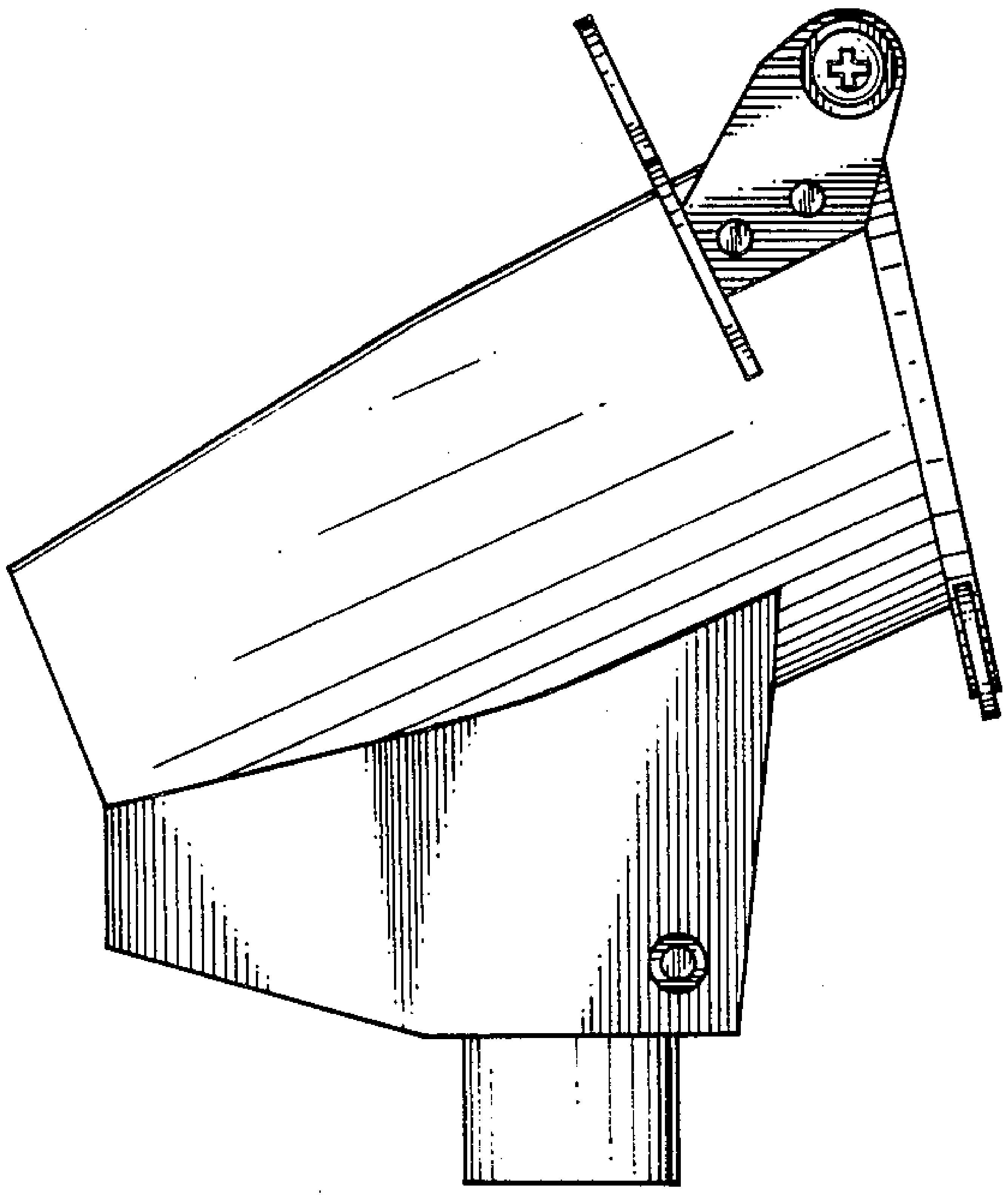

Fig. 3

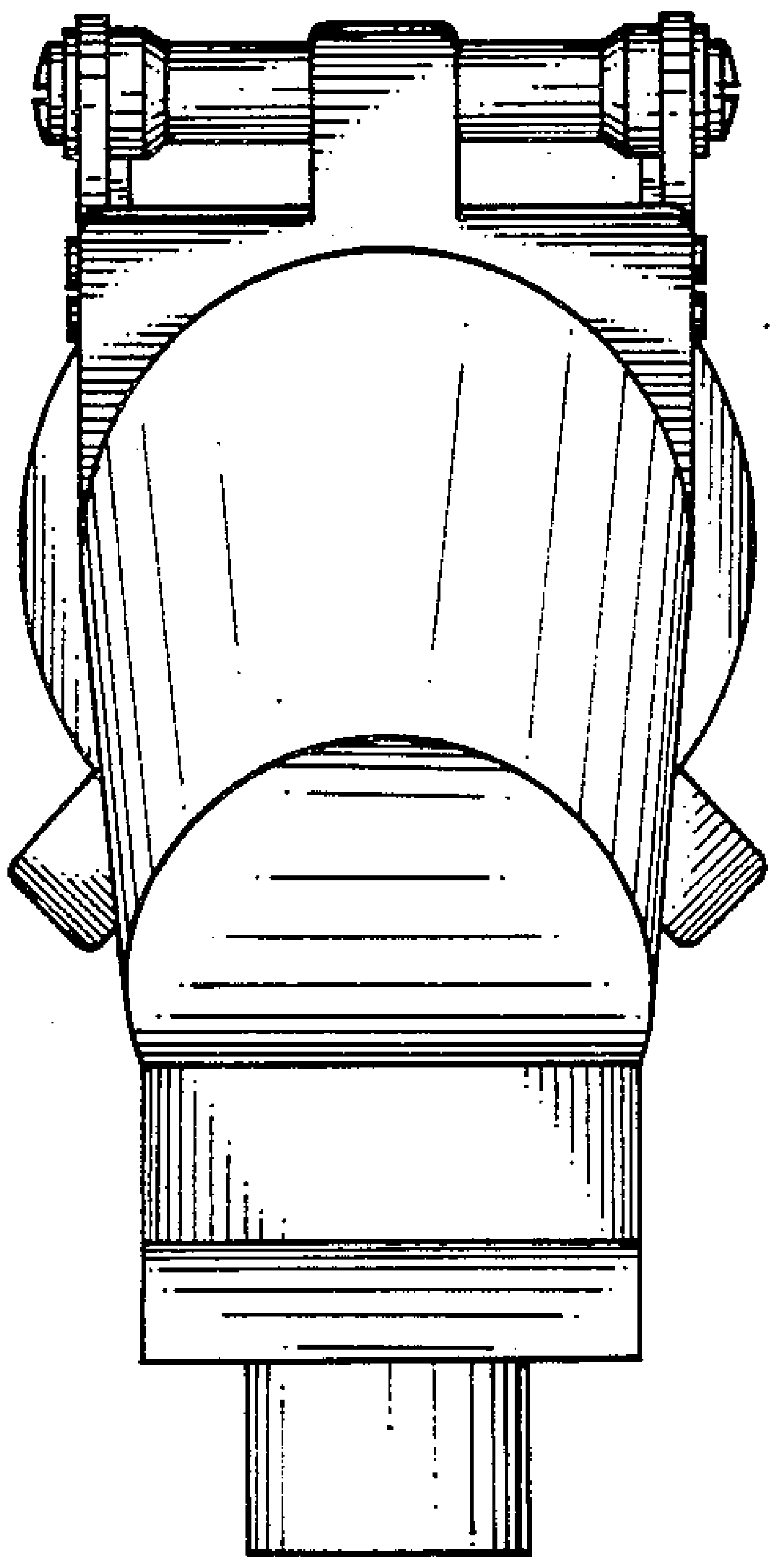

Fig. 6

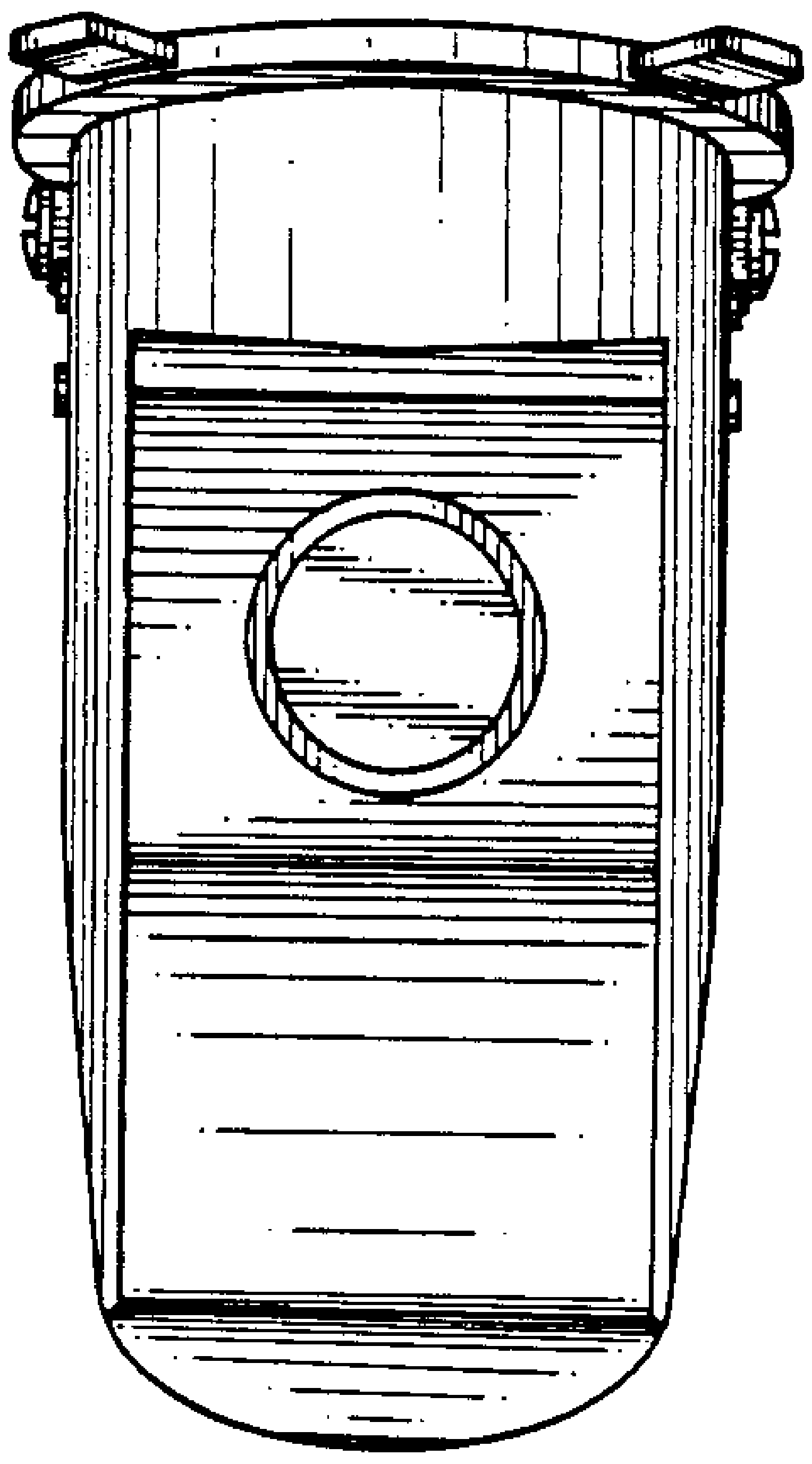

Fig. 5